

Course Manual TO

Technical optics

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– General information

Long name Technical optics

Approving CModule [TO_BaET](#), [TO_BaOPT](#)

Responsible Prof. Dr. Stefan Altmeyer
Professor Fakultät IME

Valid from summer semester 2022

Level Bachelor

Semester in the year summer semester

Duration Semester

Hours in self-study 78

ECTS 5

Professors Prof. Dr. Stefan Altmeyer
Professor Fakultät IME

Requirements mathematics:
differential calculus
integral calculus

physics / optics:
basics of geometrical optics
optics
basics of wave optics

Language German

Separate final exam Yes

Literature

Pedrotti, Pedrotti, Bausch, Schmidt: Optik für Ingenieure. Grundlagen (Springer)

Hecht: Optik (Oldenbourg)

Final exam

Details Standard for this lecture is a written exam.

If the number of participants is not too high, an oral examination is preferred over written exams.

Lowest competence level checked is knowledge. Questions could address the sign convention, the structure of the imaging equation in dependence of light direction, the definition of the principal ray or the labelling of optical components conforming to industry standards.

The next competence level is related to skills.

Examination could be done by the task to draw the optical path of rays of optical systems whereas the qualitative correct position of functional planes is important. Furthermore calculations can be performed, e.g. the resolution of optical systems, the image shift in systems with regions of differing refractive indices, of the overall focal length of a compound system.

The highest competence level addressed is methodical expertise. It can be checked by a real world task: E.g. the design of a microscope with an own light source where some application parameters to achieve are given or some off the shelf components are given. In a guided discussion or guided calculation it can be found out easily, if the underlying principles are understood and can be applied proactively, if intellectual transfer is made and if there is sufficient overview.

Minimum standard	Correct answer of at least 50 % of the questions
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Exam Type	EN Klausur
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– Lecture / Exercises

Learning goals

Goal type	Description
Knowledge	<p>magnification reproduction scale angular magnification magnifier magnification axial magnification</p> <p>cardinal planes and points node points and focal points in optical systems with asymmetric refractive indices intended shift of principal planes telephoto lens reverse telephoto lens, laser material processing</p> <p>multi lens systems analytical calculation of a doublet focal group of a camera accessory lenses for macro photos calculation of multi lens systems by repeated doublet calculation approach of lens grouping in objectives</p> <p>image shift under water photography special microscopy objectives focus with cover glass optical aberrations of plane-parallel glass sheets</p> <p>Principle of Fermat derivation of the law of refraction wave-optical explanation of the properties of a lens derivation of the sine condition</p> <p>Aperture and F# number aperture of a glass fiber of an optical imaging system F# number written F# number effective F# number relation of aperture and (effective) F# number object- and image-related apertures and F# numbers image brightness and exposure time</p> <p>diffraction at a circular aperture mathematical description</p>

Special requirements

none

Accompanying material	lecture notes as downloadable file
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Separate exam	No
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criteria for resolution
Rayleigh criterium
Sparrow criterium
size of the Airy disc
smallest resolvable distance
in the object and in the image
in terms of the apertures and F#
numbers
beneficial and empty magnification
technical examples: optical
lithography, microscope, optical
pickup for CD/DVD/blu-ray

lenses
imaging lens: glass and plastics
field lens: suitability of Fresnel
lenses, requirements regarding
dust

hard apertures and images of them
aperture stop and field stop
pupils and portholes
principal rays
complementary roles of aperture-
and field-stops in imaging- and
lighting-raypaths
principles of construction for
optical devices with own light
sources. Examples:
overheadprojector, beamer,
microscope

Microscopes
simple and joint
with and without field lens
reflection and transmission
Köhler illumination
interwoven light paths of imaging
and illumination path

If there is enough time in the
semester:

Abbe's theory of imaging
Decomposition of any object into
gratings, Fourier decomposition
Diffraction orders: number of and
phas-relationship
limiting resolution
contrast
off-axis illumination
how to build
resolution enhancement
decrease of contrast
principles of construction of a
lithography machine

Skills

Analyse, calculate and design multi lens optical systems paraxially

Shift the principal planes to intended locations in optical systems.

Convert Apertured and F# numbers on the object- and image side.

Calculate imaging resolution of optical systems on the object- and image side.

Calculate the image shift.

Calculate the resolution loss due to angular dependent image shift of high aperture systems.

Design raypaths of optical systems with integrated illumination

Transfer the principles of construction of different microscope types to other optical devices.

Calculate the contrast of optical on- and off-axis systems

Expenditure classroom teaching

Type	Attendance (h/Wk.)
Lecture	2
Tutorial (voluntary)	0

– Practical training

Learning goals

Goal type	Description
Skills	<ul style="list-style-type: none">- Build and align a Gallilei and a Kepler telescope- Determine the focal length of an objective with the method of Abbe, Bessel or different- Determine the principal planes with the method of Abbe or by extrapolation of the reproduction scale- Determine the resolution of a microscope with Köhler illumination- Determine image brightness in a microscope in dependence of reproduction scale and aperture.- Watch and compare the object and the diffraction image in the Fourier plane in a diffraction apparatus. Perform intended image manipulations by modifications in the Fourier plane. Achieve e.g. a spatial frequency doubling.- write scientific report<ul style="list-style-type: none">describe the taskdescribe the idea of the solutionexplain the experimental setupexplain the data processingmake error analysispresent the results and make a critical discussion

Expenditure classroom teaching

Type	Attendance (h/Wk.)
Practical training	2
Tutorial (voluntary)	0

Special requirements

none

Accompanying material

Instructions for the experiments as downloadable files.

Operating manuals for complex equipment as downloadable files.

Separate exam

Yes

Separate exam

Exam Type

EN Projektaufgabe im Team bearbeiten (z.B. im Praktikum)

Details

1) Written examination questions related to the experiment have to be prepared at home and shown at the beginning of the laboratory.

2) The underlying ideas of the experiment have to be explained at the beginning of the laboratory.

3) Make the experiment alone (preferred) or in a team of two.

- Build up and adjust your own setup
- Acquire / measure data with this setup

4) Write a documentation on the experiment. It will be checked with regard to

- completeness
- scientific and precise language
- correctness
- understanding of the interrelations and interpretation of the results

Minimum standard

All written tasks must have been dealt with.

The basic ideas of the experiment must have been understood.

All experiments must have been performed.

The reports must be free of systematical errors.